

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): MAKINO et al.	Atty. Dkt.: 11-231
Serial No.: Unknown	Group Art Unit:
Filed: Concurrently herewith	Examiner:
Title: SWITCHED-CAPACITOR LOW-PASS FILTER AND SEMICONDUCTOR PRESSURE SENSOR APPARATUS INCORPORATING THE FILTER	

Commissioner for Patents
Arlington, VA 22202

Date: March 4, 2004

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are submitted for consideration by the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

The Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,



David G. Posz
Reg. No. 37,701

Posz & Bethards, PLC
11250 Roger Bacon Drive, Suite 10
Reston, VA 20190
(703)707-9110 (phone)
Customer No. 23400

Form PTO-1449		ATTORNEY DOCKET NO.	SERIAL NO.
<p>PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITIGATION (Use several sheets if necessary)</p> <p>Sheet 1 of <u>1</u></p>		11-231	
		APPLICANT	
		Takanori MAKINO et al.	
FILING DATE	GROUP		
March 4, 2004			

U.S.PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date

FOREIGN PATENT DOCUMENTS						English Abstract	
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Yes	No
		63-219219	9/12/88	Japan		X	
		9-27731	1/28/97	Japan		X	
		9-199994	7/31/97	Japan		X	
		2001-165797	6/22/01	Japan		X	
		2002-39888	2/6/02	Japan		X	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	

EXAMINER:	Date Considered:
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EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.